# **Panasonic BUSINESS**







- Contribute to low cost production for high value added devices (High yield and high productivity)
  - Productivity improved by 11% (compared with MD-P200US)
- Realize high quality metal joint, thanks to stable ultrasonic vibration provided by high rigidity US head with heating function
- **●** Ensure stable quality and traceability thanks to real time monitoring function

Model ID	MD-P200US2
Model No.	NM-EFF1D
Productivity*1	0.65 s / IC for thermosonic bonding (Including process time of 0.2 seconds. Under the fastest conditions)
Placement accuracy *1	XY (3σ at PFSC conditions) :±7 μm
Substrate dimensions	L 50 mm × W 30 mm to L 120 mm × W 120 mm
Die dimensions	L 0.25 mm × W 0.25 mm to L 6 mm × W 6mm
Number of die types	1 product type (manual wafer supply) / Up to 12 product types (AWC specifications) *Nozzle is one type
Die supply	Wafer frame (Max. 8 inch) , Tray
Bonding load	VCM head for thermosonic process : 1 N to 50 N (Option : 2 N to 100 N)
Head heating	Up to 300℃ for the VCM head
Substrate heating	Constant heating, Up to 300℃
Power source *2	3-phase AC 200 V ±10V, 50 / 60 Hz, Up to 1.7 kVA (Up to 7.5 kVA for heating specification)
Pneumatic source	0.4 to 0.5 Mpa (Max. 0.8 Mpa), 30 L / min (A.N.R.) (Up to 150 L / min for full-featured machine including cooling air)
Dimensions	W 1 340 mm × D 1 140 mm × H 1 400 mm (Including loader/unloader)
Mass	1 750 kg(Including loader / unloader)

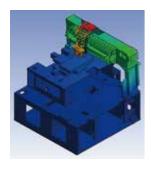
<sup>\*1:</sup>The described productivity and placement accuracy may differ depending on the conditions of use.

\*2:Three phase 208 / 220 / 380 / 400 / 415 / 480

For details, refer to the specification.

#### Productivity improved by 11% (compared with MD-P200US)

High rigidity design and improved IC quick pick up motion brings improved productivity by 11% (0.65 s / IC), while keeping high accuracy of  $\pm 7$  um /  $3\sigma$ , and high productivity.



(High rigidity design)·High rigidity frame·light weight bonding head

#### Real time US monitoring function

Real time US monitoring function realizes stable quality by monitoring process parameters during production.



#### Variation of advanced software functions

Various advanced software functions (option) will fulfill various requirement, depending on purposes

\*Please refer to specifications for more detail.



## Unnecessary to prepare for additional equipment



- Inspection function
  - · Bump existing inspection
  - · Post bond inspection
- Productivity improvement / Automated function
  - · Search height learning, and others



Machine

◆GEM (SEMI-E30)



**♦**Wafer mapping

Substrate mapping

♦Multi-rank bonding



Wafer mapping image

### Safety Cautions

 Please read the User's Manual carefully to familiarize yourself with safe and effective usage procedures. To ensure safety when using this equipment, all work should be performed according to that as stated in the supplied Operating Instructions. Read your operating instruction manual thoroughly.

Panasonic Group products are built with the environment in mind.

Please check the homepage for the details. panasonic.com/global/corporate/sustainability

Inquiries...

Panasonic Corporation Process Automation Business Division

3-1-1 Inazu-cho, Toyonaka City, Osaka 561-0854, Japan TEL +81-6-6866-8630 FAX +81-6-6862-0422

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